Group Art Unit: 2891 Examiner: Asok K. Sarkar

In Re PATENT APPLICATION of:

Applicant(s): Masaru Takaishi

Serial No.: 10/809,682

Filing Date: March 26, 2004

For: METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICE AND

SEMICONDUCTOR DEVICE

Atty. Docket: Al 332

RESPONSE TO RESTRICTION REQUIREMENT

November 17, 2005

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Restriction Requirement mailed on October 6, 2005, Applicant elects the invention of Group II, i.e., the subject matter of claims 6-13, for further examination. The election is made without traverse. Also attached to this Response is a Petition for One-month Extension of Time, extending the period for response to December 6, 2005.

Examination of the application on the merits is respectfully requested.

Should the remittance be accidentally missing or insufficient, the Commissioner is hereby authorized to charge the fee to our Deposit Account No. 18-0002, and advise us accordingly.

November 17, 2005

Date

Respectfully submitted,

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RHB:vm